

IFW



Attorney's Docket No.: 14225-020001 / F1030443US00

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takayuki Tani et al.
Serial No. : 10/650,433
Filed : August 28, 2003
Title : SEMICONDUCTOR DEVICE

Art Unit : 2826
Examiner : Alexander Williams

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MARCH 26, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

June 9, 2004

Date of Deposit

Signature

Rose Papetti

Typed or Printed Name of Person Signing Certificate